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Attorney Docket No. 10972039-2

R&A No. 5000-0029

PATENT

November 21, 2000

11/21/00
Date

Marilyn B. McKenna
Signature

11/28/00
#8/IDS

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Application of:

Reid A. Brennen et al.

Serial No.: 09/233,694

Filing Date: January 19, 1999

Group Art Unit: 1756

Examiner: C. Young

Title: METHOD FOR PRODUCING HIGH-SURFACE AREA TEXTURING OF A SUBSTRATE, SUBSTRATES PREPARED THEREBY AND MASKS FOR USE THEREIN

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT
AND PETITION FOR CONSIDERATION THEREOF

Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

This is a Supplemental Information Disclosure Statement submitted for the Examiner's consideration. Applicants respectfully request that the Examiner review and make of record the references identified below.

The undersigned hereby certifies that that no item of information contained in this Supplemental Information Disclosure statement was cited in a communication from a foreign patent office in a counterpart foreign application or to the knowledge of the person signing the certification after making reasonable inquiry, was known to any individual designated in § 1.56(c) more than three months prior to the filing of the statement. (37 CFR §1.97(e)(2)).

Copies of the information are also submitted herewith. The Examiner is requested to make this information of official record in the application.

Form PTO-1449 listing the references accompanies this paper. Applicants would appreciate the Examiner's initialing and returning the form to indicate that the references have been reviewed and made of record. The references are as follows:

11/28/2000 AGOITOM 00000046 09233694

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OTHER DOCUMENTS
Becker et al. (1998), "Planar Quartz Chips with Submicron Channels for Two-Dimensional Capillary Electrophoresis Applications," <i>J. Micromech. Microeng.</i> 8:24-28.
He et al. (1998), "Fabrication of Nanocolumns for Liquid Chromatography," <i>Anal. Chem.</i> 70(18):3790-3797.

This Supplemental Information Disclosure Statement is not intended as a representation that a search has been made, that additional information material to the examination of this application does not exist or that any of the above references constitutes prior art to the present application within the meaning of 35 USC § 102.

As a final action has just been issued, applicants, hereby petition under 37 CFR § 1.97(d)(2) to have this disclosure statement considered.

The petition fee of \$130 is submitted herewith.

Please charge any shortages or credit any overages of fees to Deposit Account No. 18-0580.

Respectfully submitted,

Nov 21, 2000

Date

By:

Louis L. Wu

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